



Docket No.: 50432-096

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|--|---|------------------------------|
| In re Application of | : | Customer Number: 20277 |
| Calvin T. GABRIEL, et al. | : | Confirmation Number: 7774 |
| Serial No.: 09/887,165 | : | Group Art Unit: 1763 |
| Filed: June 25, 2001 | : | Examiner: George A. Goudreau |
| For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST POISONING | : | |

AMENDMENT

Mail Stop No Fee - Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendment and remarks are respectfully submitted in response to the Office Action dated October 3, 2002. This Office Action was never received, as detailed in the Petition For Reconsideration of Holding of Abandonment filed on even date herewith. This amendment comprises a complete response to the original Official Action of October 3, 2002 and entry of this amendment is respectfully requested.